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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Application Number			PĒ				
Filing Date	09/27/2001	FI					
First Named Inventor	Albert Edward Moore, Jr.	S					
Group Art Unit	IPEA	579					
Examiner Name	Not Assigned						
Attorney Docket Number	Moore.A-02	38					

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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check-mark here if English language Translation is attached.



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